



Attorney Docket No. 0756-2424

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Osamu NAKAMURA et al.

Serial No. 10/046,893

Filed: January 17, 2002

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2823

) Examiner: H. Lee

) CERTIFICATE OF MAILING

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Adelle M. Stampen

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated May 22, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

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